

Electronic Patent Application Fee Transmittal

Application Number:	10585994			
Filing Date:	13-Jul-2006			
Title of Invention:	MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND FILM DEPOSITION SYSTEM			
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Filer:	Michael A. Makuch/Cynthia Johnson			
Attorney Docket Number:	33082M336			
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U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	1	3	3
Total in USD (\$)				1813